


**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s) : Silvia Kronmueller et al.  
Serial No. : 10/518,065  
Filing Date : July 21, 2005  
For : COMPONENT INCLUDING A FIXED  
ELEMENT THAT IS IN A SILICON LAYER  
AND IS MECHANICALLY CONNECTED  
TO A SUBSTRATE VIA AN ANCHORING  
ELEMENT AND METHOD FOR ITS  
MANUFACTURE (as amended)  
Examiner : Stephen W. Smoot  
Group Art Unit : 2813  
Confirmation No. : 2716  
**Customer No. : 26646**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria VA 22313-1450

I hereby certify that this correspondence is being electronically transmitted to the United States Patent and Trademark Office via the Office electronic filing system on *February 11, 2008*.

Signature: 

Aaron Grunberger (Reg. No. 59,210)

**AMENDMENT**

SIR:

In response to the Office Action of November 9, 2007 (the three-month response date for which is February 11, 2008 (since February 9, 2008 is a Saturday)), please reconsider the above-identified application based on the following.

**Amendments to the Specification** begins on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 3 of this paper.

**Remarks** begin on page 7 of this paper.